Electronic Acknowledgement Receipt				
EFS ID:	2866491			
Application Number:	10516455			
International Application Number:				
Confirmation Number:	2876			
Title of Invention:	Method and device for substrate etching with very high power inductively coupled plasma			
First Named Inventor/Applicant Name:	Michel Puech			
Customer Number:	23373			
Filer:	Michael R. Dzwonczyk/Lynette Mansfield			
Filer Authorized By:	Michael R. Dzwonczyk			
Attorney Docket Number:	Q84452			
Receipt Date:	15-FEB-2008			
Filing Date:	03-DEC-2004			
Time Stamp:	13:25:30			
Application Type:	U.S. National Stage under 35 USC 371			

Payment information:

Submitted with Payment	yes
Payment Type	Deposit Account
Payment was successfully received in RAM	\$1050
RAM confirmation Number	9020
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)			
1		Q84452Amendment.pdf	225074	yes	7			
			3610f9c9a010604e29e00824d27aacf1 a8c89354					
	Multipart Description/PDF files in .zip description							
	Document Description		Start	End				
	Amendment - After Non-Final Rejection		1	1				
	Claims		2	3				
	Applicant Arguments/Remarks Made in an Amendment		4	6				
	Extension of Time		7	7				
Warnings:								
Information:								
2 Fee V	Fee Worksheet (PTO-06)	fee-info.pdf	8212	no	2			
	, 33 (10)(0)(0)		c38ee4310ff0675a146e4d29b1df927ea 0932e9f					
Warnings:								
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If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

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